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GNM/cc

Paper No.: \_\_\_\_

**IN THE UNITED STATES PATENT & TRADEMARK OFFICE**


Inventor(s): NEUFELD, Richard D.; TRAUTMAN, Christopher E.  
Title: **METHOD FOR LINEARIZATION OF AN ACTUATOR VIA FORCE  
GRADIENT MODIFICATION**  
Serial No.: 09/813839  
Filed: 22 March 2001  
Examiner: TAMAI, Karl I. Art Unit: 2834  
Date: 27 August 2003

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

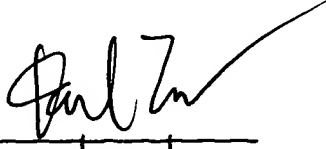
**LIST OF PATENTS AND PUBLICATIONS FOR  
APPLICANT'S INFORMATION DISCLOSURE STATEMENT  
[Form PTO-1449 (Modified)]**

Other Art

Examiner	ID	Author, Title, Date, Pertinent Pages, etc.
	OA: 1	Dawson et al. <i>Through-wafer optical probe characterization for microelectromechanical systems positional state monitoring and feedback control</i> . 6 July 2000.

Examiner:

Date Considered:

  
5/22/2004

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.